

648.42568VX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): G. MIYA, et al
Serial No.: (not yet assigned)
Filed: February 18, 2004
For: PLASMA PROCESSING APPARATUS AND PLASMA
PROCESSING METHOD

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 18, 2004

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendment of the Specification and Abstract;
Amendment of the Claims; and
Remarks are included following the amendments.